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IN THE UNITED STATES PATENT AND TRADEMARK OF

Applicants:

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Assignee:

Nanometrics Incorporated

Title:

Apparatus And Method For The Measurement Of Diffracting Structure

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COMMISSIONER FOR PATENTS

Washington, D. C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT **UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying PTO Form-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

- an admission that the documents are necessarily prior art with respect to the 1. instant invention:
 - 2. a representation that a search has been made; or
- 3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in $\S 1.56(b)$.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. on January 30, 2002

Respectfully submitted,

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